

Title: SYSTEM AND METHOD FOR PULSE LASER DEPOSITION

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1 / 5

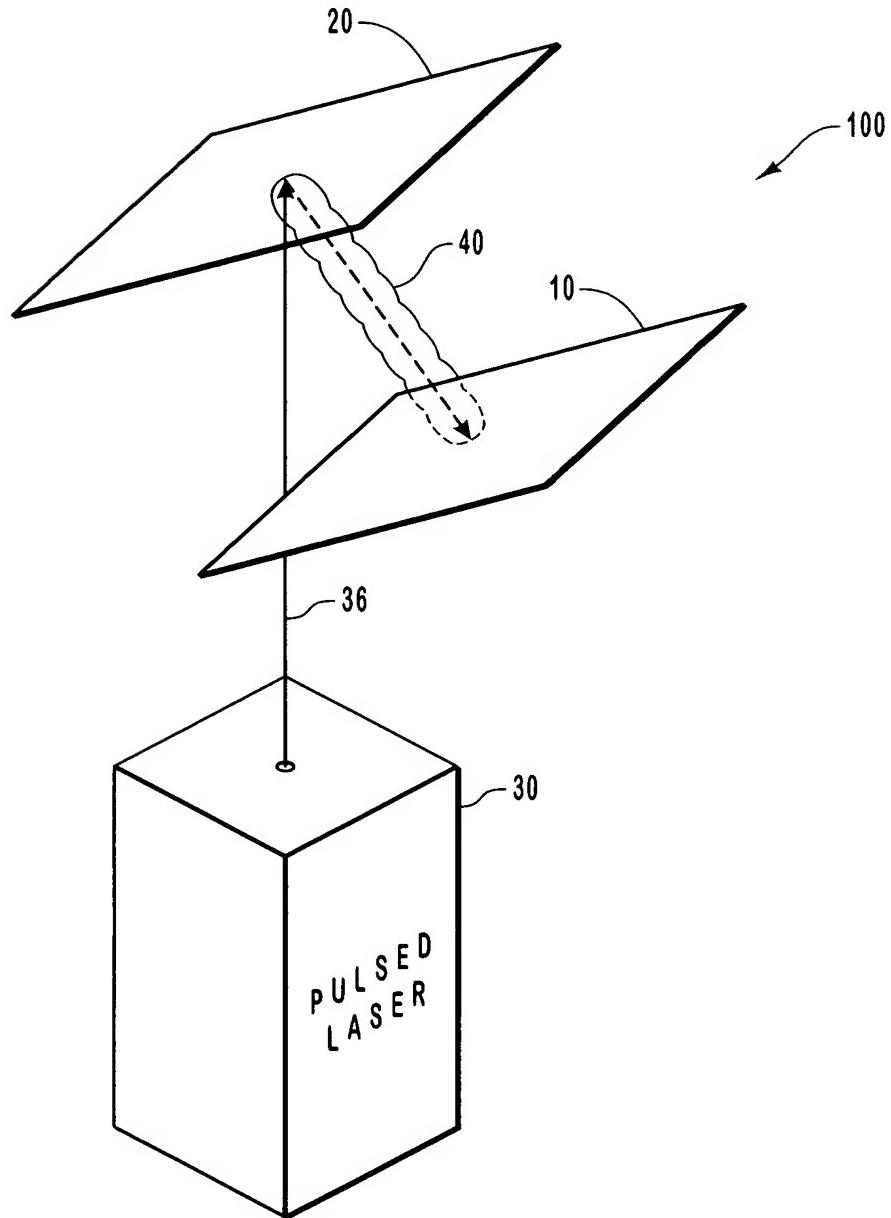


FIG. 1
(Prior Art)

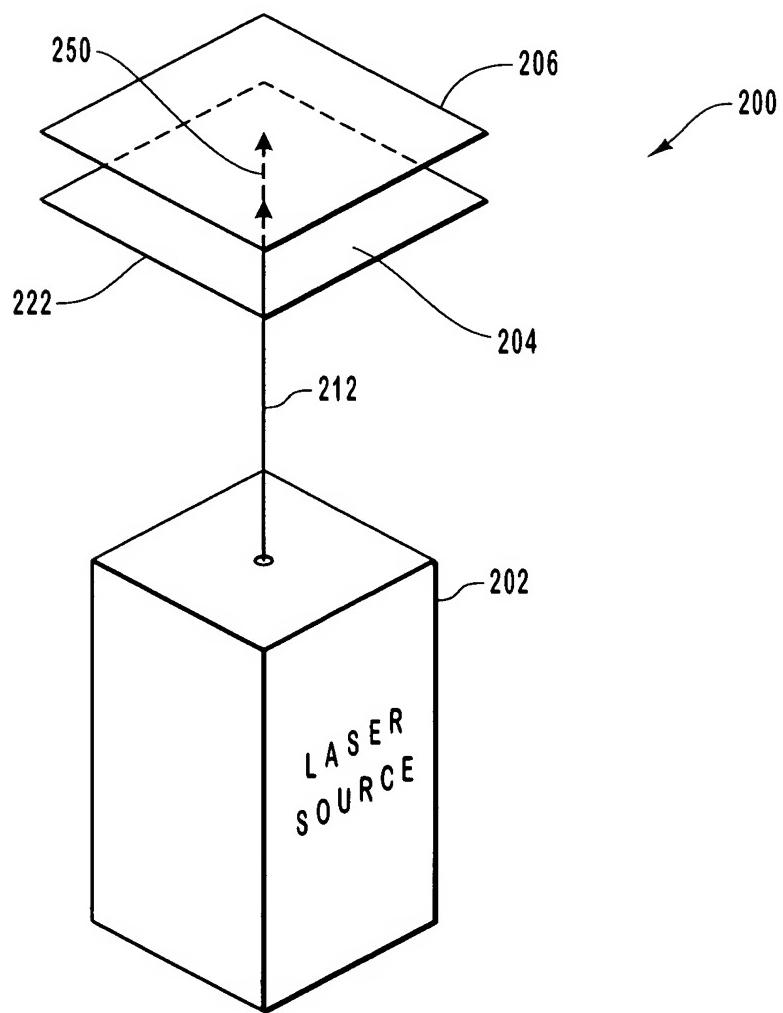


FIG. 2

3 / 5

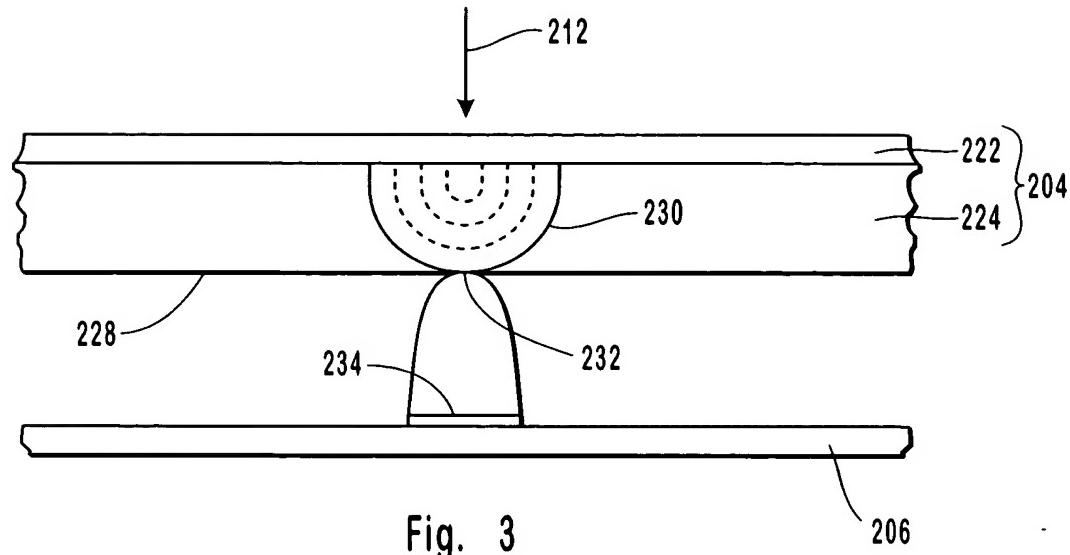


Fig. 3

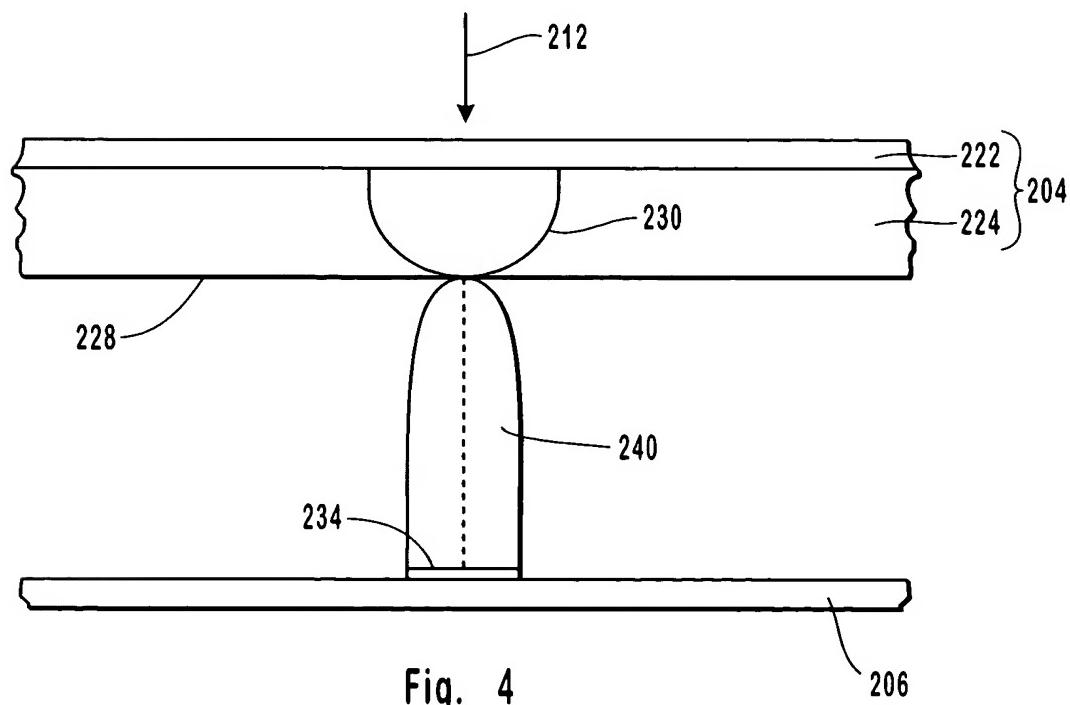


Fig. 4

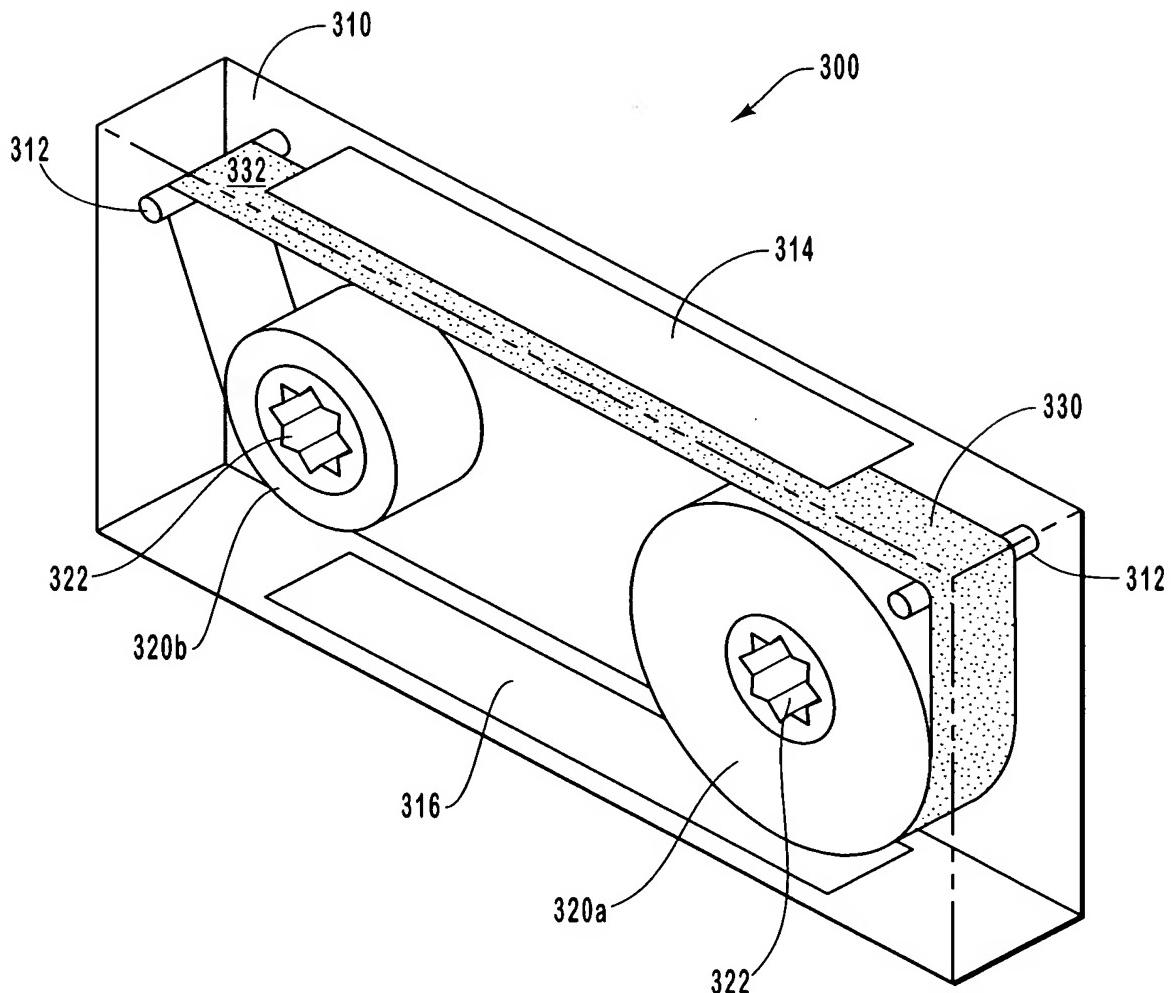


FIG. 5

5 / 5

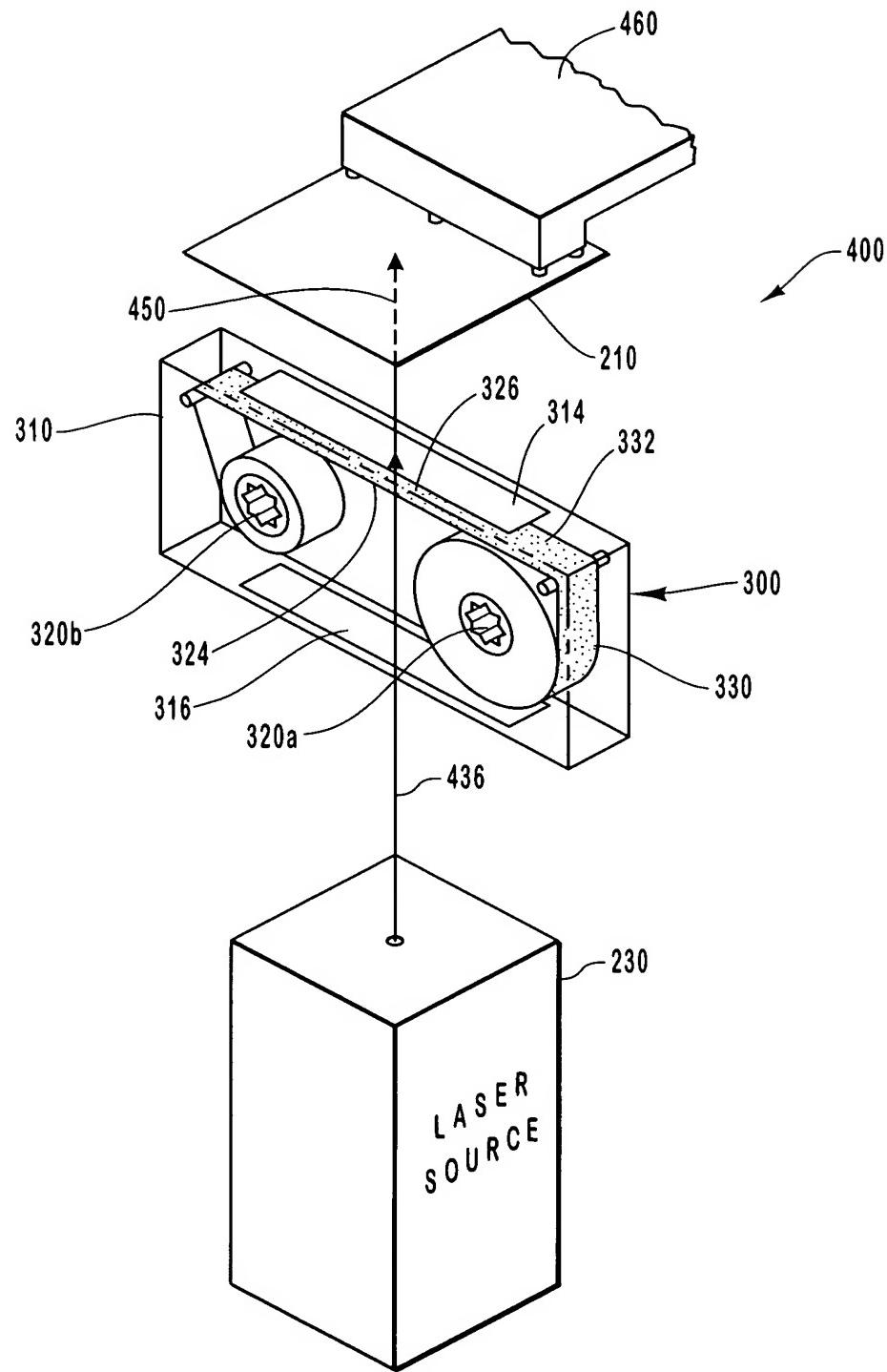


FIG. 6